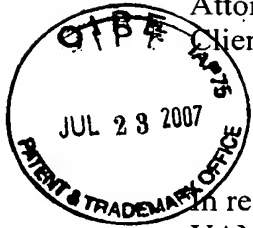


IFw

Attorney Docket: 081468-0306523

Client Reference: P-0371.010-US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
VAN DER WERF, ET AL.

Confirmation Number: 6464

Application No.: 10/693,603

Group Art Unit: 2886

Filed: October 27, 2003

Examiner: Michael Patrick Stafira

Title: METHOD OF DETECTING MASK DEFECTS, A COMPUTER PROGRAM AND
REFERENCE SUBSTRATE

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450 – Mail Stop AF
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 23, 2007, please take the following
remarks into consideration: